



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 19, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG810637864

LABORATORY GROWN DIAMOND

CUT CORNERED RECTANGULAR
MODIFIED BRILLIANT

9.04 X 6.21 X 4.24 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.08 CARATS

F

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

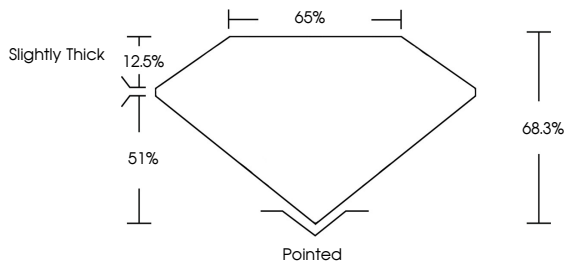
NONE

Inscription(s)

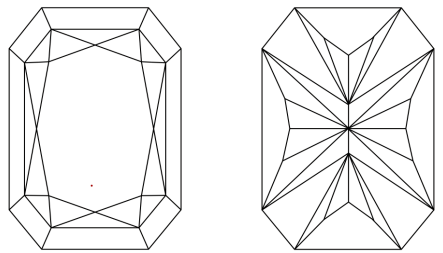
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

 LG810637864

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

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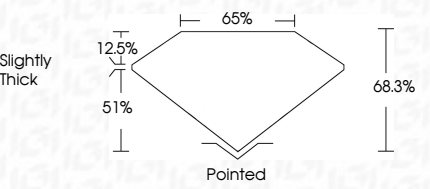
NONE

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PROPORTIONS



COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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June 19, 2026

IGI Report No LG810637864

CUT CORNERED RECT. MODIFIED BRILLIANT

9.04 X 6.21 X 4.24 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

2.08 CARATS

F

VVS 2

68.3%

65%

Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE

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Culet

Polish

Symmetry

Fluorescence

Inscription(s)

NONE

EXCELLENT

EXCELLENT

NONE

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